

Application/Control No.	Applicant(s)/Patent under Reexamination
10/579,194	LEE ET AL.
Examiner	Art Unit
Krishnan S. Menon	1797

	SEARCHED				
Class	Subclass	Date	Examiner		

INTERFERENCE SEARCHED				
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SEARCH NO (INCLUDING SEARCH)
	DATE	EXMR
Inventor search; 210/650,652,321.69,500.23, 490	11/6/2008	KM
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